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Applicant(s): Nosowitz, N., et al

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Docket No.

IR 3700 NP

Serial No.

10/706,178

Filing Date

11/12/03

Examiner

not yet assigned

Group Art Unit

not yet assigned

Invention: Composition and Method for Copper Chemical Mechanical Planarization

I hereby certify that this Information Disclosure Statement & attached Info. Disclosure Citation w/ references
(Identify type of correspondence)

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PATENT

Attorney Docket No. IR 3700 NP

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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INFORMATION DISCLOSURE STATEMENT

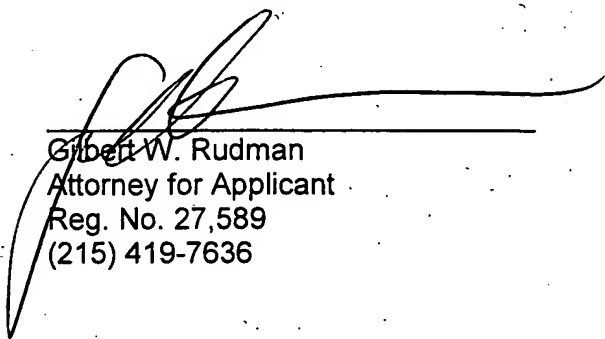
Commissioner for Patents
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Sir:

Applicant submits herewith a copy of the documents listed on the attached Form PTO-1449.

Respectfully submitted,


Date: 2/11/04



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Encls.

<div style="text-align: center;">  <p>INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)</p> </div>	ATTY DOCKET NO. IR 3700 NP	SERIAL NO. 10/706,178
	Nosowitz, M., et al.	
	FILING 11/12/03	GROUP n/a

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
A1	09/091,932		Kaisaki, et al.			6/24/98
A2	6,117,783	12/12/00	Small, et al.			
A3	4,233,112	11/11/80	Valayil, et al.			
A4	6,117,795	12/12/00	Pasch			
A5	6,068,879	5/30/00	Pasch			
A6	5,073,577	12/17/91	Anderson			
A7	5,177,908	1/12/93	Tuttle			
A8	5,234,867	8/10/93	Schultz, et al.			
A9	5,297,364	3/29/94	Tuttle			
A10	5,486,129	1/23/96	Sandhu, et al.			
A11	5,230,184	7/27/93	Bukhman			

FOREIGN PATENT DOCUMENTS

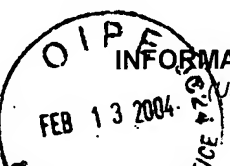
DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
					YES	NO
B1	WO/9711484	3/27/97	PCT			✓
B2	WO/01/44396	6/21/01	PCT			✓
B3	WO/0112741	2/22/01	PCT			✓

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	C1	Production of Sulfide Minerals by Sulfate-Reducing Bacteria During Microbiologically Influenced Corrosion of Copper, McNeil, Jones, and Little

EXAMINER	DATE CONSIDERED
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

 INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)	ATTY DOCKET NO. IR 3700 NP	SERIAL NO. 10/706,178
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	FILING 11/12/03	GROUP n/a

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A12	5,245,790	9/21/93	Jerbic			
	A13	5,562,530	10/8/96	Runnels, et al.			

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER	DATE CONSIDERED
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